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PATENT

Attorney Docket No. 0553-0255

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:)
Yamazaki et al.)
Serial No: 09/841,537 ✓)
Filed: April 24, 2001)
Art Unit: 2822)
Examiner: M. Prenty)
For: A SEMICONDUCTOR DEVICE)
And Method Of Fabricating))
Thereof)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

September 9, 2003

Signature *James L. Cullen*

Date September 9, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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AMENDMENT C

Dear Sir:

In response to the Office Action dated June 10, 2003,
please amend the above-identified application as follows.

IN THE CLAIMS:

Please amend claims 1, 10, 19 and 27 as follows.

1. (currently amended) A semiconductor device comprising:

a thin film transistor comprising a semiconductor layer
over a substrate and a gate electrode with an insulating film
interposed therebetween;

CI